

<b>Form 1449 (Modified)</b>				Atty. Docket No. HIT1P010/ SJ09-2002-0123US1	Application No.: <b>10/617,908</b>
<b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)				Applicant: Kim Y. Lee et al	Group Art Unit: <b>3729</b>
				Filing Date: Herewith <b>07/10/2003</b>	

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
TN	A	6,219,207	4/17/01	Pinarbasi	360	322	4/26/99
TN	B	2001/0001256	5/17/01	Hsiao	360	246.6	1/16/01
TN	C	5,978,183	11/2/99	Hsiao et al.	360	113	12/11/97
TN	D	6,162,582	12/19/00	Hsiao et al.	430	312	6/25/99
TN	E	2001/0028537	10/11/01	Gill	360	314	6/1/01
	F						
	G						
	H						
	I						
	J						
	K						
	L						

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes
M							
N							
O							
P							

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
R		
S		
T		
Examiner		Date Considered
/Tai Nguyen/		05/12/2006

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

05/12/2006